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<b>APPLICANTS</b> Lee Jen Chen, Hsinchu, TAIWAN; Kuang-Chao Chen, Hsinchu, TAIWAN; Chin-Hsiang Lin, Hsinchu, TAIWAN;					
<b>** CONTINUING DATA *****</b> <i>NOTE</i>					
<b>** FOREIGN APPLICATIONS *****</b> <i>NOTE</i>					
<b>IF REQUIRED, FOREIGN FILING LICENSE GRANTED</b> <b>** 12/02/2003</b>					
Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after met <i>Allowance</i> <i>h</i> Verified and Acknowledged <i>h</i> Examiner's Signature Initials		<b>STATE OR COUNTRY</b> TAIWAN	<b>SHEETS DRAWING</b> 2	<b>TOTAL CLAIMS</b> 24	<b>INDEPENDENT CLAIMS</b> 3
<b>ADDRESS</b> Stout, Uxa, Buyan & Mullins, LLP 4 Venture, Suite 300 Irvine, CA92618					
<b>TITLE</b> Method for mitigating chemical vapor deposition phosphorus doping oxide surface induced defects					
<b>FILING FEE RECEIVED</b> 1772	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		